



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application Of:) Confirmation no. 7871
)
Won Hwa JIN) Group Art Unit: 2823
)
Application Number: 10/608,082) Examiner: W. Brewster
)
Filed: July 30, 2003)
)
For: METHOD FOR FORMING METAL LINE OF SEMICONDUCTOR DEVICE

CHANGE OF CORRESPONDENCE ADDRESS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

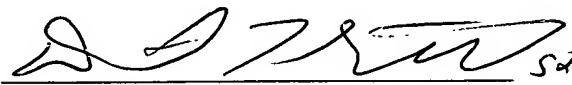
Sir:

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